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S/N 10/825,033

**PATENT** 

## PATENT AND TRADEMARK OFFICE

Applicant:

**FUJIMORI** 

Examiner:

K. Lee

Serial No.:

10/825,033

Group Art Unit:

2812

Filed:

April 14, 2004

Docket No.:

12844.0015USD1

Title:

METHOD OF MANUFACTURING FERROELECTRIC SUBSTANCE

THIN FILM AND FERROELECTRIC MEMORY USING THE

FERROELECTRIC SUBSTANCE THIN FILM

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.

2007.

## **CHANGE OF ADDRESS**

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

Please change the correspondence address for the above-referenced patent application to:

Hamre, Schumann, Mueller & Larson, P.C.

P.O. Box 2902 Minneapolis, MN 55402-0902

If there are any questions regarding this matter, please call the undersigned at

612.455.3800.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER & LARSON, P.C. P.O. Box 2902-0902

Minneapolis, MN 55402-0902

(612) **4**53-**3**800

Dated: February 13, 2007

By:

Douglas P. Mueller

Reg. No. 30,300

DPM/pjk